

**Notice of References Cited**

Application/Control No.

10/526,427

Applicant(s)/Patent Under

Reexamination

TAKAGAWA ET AL.

Examiner

JOHN A. HEVEY

Art Unit

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**U.S. PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A US-5,518,642 A	05-1996	Inoue et al.	252/62.56
B	US-			
C	US-			
D	US-			
E	US-			
F	US-			
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H	US-			
I	US-			
J	US-			
K	US-			
L	US-			
M	US-			

**FOREIGN PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
N					
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P					
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R					
S					
T					

**NON-PATENT DOCUMENTS**

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
U	Kono et al. JP 11-003813, Published 6/1/1999 (machine translation)
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a))  
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